



Docket No.: 9323.053.00-US
(PATENT)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
In-Kwon Jeong

Confirmation No.: 68 **RECEIVED**

Application No.: 09/780,713

Art Unit: 3743 MAY 10 2004

Filed: February 8, 2001

Examiner: L. V. C. **OFFICE OF PETITIONS**

For: MULTI-CHANNEL TEMPERATURE
CONTROL SYSTEM FOR SEMICONDUCTOR
PROCESSING FACILITIES

Customer No.: 30827

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 31, 2002 (Paper No. 4), please amend the
above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on
page 3 of this paper.

Amendments to the Abstract begin on page 10 of this paper.

Remarks/Arguments begin on page 11 of this paper.

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